

## IN THE U.S. PATENT AND TRADEMARK OFFICE

I N F O R M A T I O N   S H E E T

Applicant: FUJIMURA, Shigeto  
ASAHI, Toshiaki  
SATO, Kenji

Application No.:

Filed: January 4, 2001

For: PROCESS FOR PRODUCING COMPOUND SEMICONDUCTOR SINGLE CRYSTAL

Priority Claimed Under 35 U.S.C. 119 and/or 120:

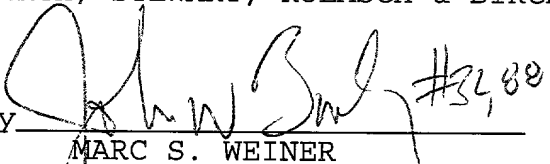
| COUNTRY | DATE     | NUMBER    |
|---------|----------|-----------|
| JAPAN   | 01/07/00 | 2000-1675 |

Send Correspondence to: BIRCH, STEWART, KOLASCH & BIRCH, LLP  
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(703) 205-8000

The above information is submitted to advise the USPTO of all relevant facts in connection with the present application. A timely executed Declaration in accordance with 37 CFR 1.64 will follow.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By  #32,181

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